

<b>Notice of References Cited</b>	Application/Control No. 09/873,939	Applicant(s)/Patent Under Reexamination ENAM ET AL.	
	Examiner Shuwang Liu	Art Unit 2634	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	B	US-5,726,991	03-1998	Chen et al.	714/704
	C	US-5,610,826	03-1997	Whetsel, Lee D.	702/117
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	L	US-			
	M	US-			

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**NON-PATENT DOCUMENTS**

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